



PTO/SB/08A (10-01)

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Sheet

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of

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Complete if Known

Application Number	10/666,930
Filing Date	September 19, 2003
First Named Inventor	Farnworth et al.
Group Art Unit	2812
Examiner Name	Unknown <u>Isaac</u>
Attorney Docket Number	5529US (02-0766.00/US)

U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
SDI		US-6,251,488	06/26/01	Miller et al.	
		US- 6,259,962	07/10/01	Gothait	
		US- 6,268,584	07/31/01	Keicher et al.	
		US- 6,391,251	05/21/02	Keicher et al.	
		US- 6,562,661	05/13/03	Grigg	
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FOREIGN PATENT DOCUMENTS

Examiner Initials *	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				

Examiner
SignatureStanetta BaacDate
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¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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Examiner Name	Unknown
Attorney Docket Number	55291US (02-0766 00/US)

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
SDI		U.S. Patent Application Publication 2002/0171177 A1 to Krichman et al., dated November 21, 2002	
		U.S. Patent Application Publication 2003/0151167 A1 to Krichman et al., dated August 14, 2003	
		U.S. Patent Application Publication 2003/0176021 A1 to Grigg, dated September 18, 2003	
		MILLER et al., "Maskless Mesoscale Materials Deposition", Deposition Technology, September 2001, pages 20-22	
		MILLER, "New Laser-Directed Deposition Technology", Microelectronic Fabrication, August 2001, page 16	
		Webpage, Objet Prototyping the Future, "Objet FullCure700 Series", 1 page	
		Webpage, Objet Prototyping the Future, "How it Works", 2 pages	
		U.S. Patent Application No. 09/512,203, filed February 24, 2000, entitled "Tape Stiffener, Semiconductor Device Component Assemblies Including Same, and Stereolithographic Methods for Fabricating Same", inventor Ford B. Grigg	
		U.S. Patent Application No. 10/666,742, filed September 19, 2003, entitled "Support Structure for Thinning Semiconductor Substrates and Thinning Methods Employing the Support Structure", inventor Wood et al.	

Examiner
Signature*Hanetta Baac*Date
Considered*3/4/05*

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